

Notice of References Cited	Application/Control No. 10/525,651		Applicant(s)/Patent Under Reexamination KIMURA ET AL.	
	Examiner Kwang Han		Art Unit 1795	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,117,579	09-2000	Gyoten et al.	429/30
*	B	US-4,125,676	11-1978	Maricle et al.	429/38
*	C	US-2002/0187380	12-2002	Tanaka et al.	429/34
*	D	US-4,883,717	11-1989	Kitamura et al.	428/458
*	E	US-5,642,413	06-1997	Little, Randall P.	379/374.02
*	F	US-5,879,826	03-1999	Lehman et al.	429/13
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Online translation of JP 2002-231290, Hatanaka et al., August 16, 2002			
	V	Online translation of JP 08-287941, Takahashi, November 1, 1996			
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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